

<b>Notice of References Cited</b>	Application/Control No. 10/644,996	Applicant(s)/Patent Under Reexamination CHUN, CHANG-HYEN	
	Examiner Pierre-Louis Desir	Art Unit 2617	Page 1 of 1

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*	B	US-6,236,860	05-2001	Hagting et al.	455/436
*	C	US-2004/0114574	06-2004	Zeira et al.	370/352
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**NON-PATENT DOCUMENTS**

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